

Title (en)  
Continuous polishing apparatus

Title (de)  
Durchlauf - Polieranlage

Title (fr)  
Appareil de polissage continu

Publication  
**EP 0838307 A1 19980429 (DE)**

Application  
**EP 97118627 A 19971028**

Priority  
DE 19644723 A 19961028

Abstract (en)

The polishing unit is made of a chain belt (3) fitted with polishing discs. The unit can have a pick-up belt and-or a bottle guide and-or a threading device and-or a tensioning device and-or a device for turning bottles about their own axis. Inclined polishing rollers can be provided,. A device measures and controls the pressure ratios relative to the polishing discs and-or polishing rollers which press on the plastics surfaces. Drive motors for the polishing members can be vertical and-or horizontal.

Abstract (de)

Die Erfindung betrifft eine Durchlauf-Polieranlage für Kunststoffbehälter, die aus einem Kettenband (3) besteht, an dem Polierscheiben (4,5) angeordnet sind und die vorzugsweise als Durchlauf-Polierautomat ausgebildet ist. <IMAGE>

IPC 1-7

**B24B 19/00; B24B 5/50; B24B 29/04**

IPC 8 full level

**B24B 5/50 (2006.01); B24B 19/00 (2006.01); B24B 29/04 (2006.01)**

CPC (source: EP)

**B24B 5/50 (2013.01); B24B 19/006 (2013.01); B24B 29/04 (2013.01)**

Citation (search report)

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